

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
ANTONIUS H.M. RAAIJMAKERS ET AL.

Atty. Docket
PHN 17,819

Serial No. 09/745,914

Group Art Unit:

Filed: DECEMBER 22, 2000

Examiner:

Title: ELECTRO-OPTICAL HAVING AN ITO LAYER, A SIN LAYER AND AN
INTERMEDIATE SILICON OXIDE LAYER

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.97

Sir:

Enclosed is a Form PTO-1449 and copies of documents listed thereon. These documents are considered to be relevant in that they have been:

considered in drafting the specification of the above-referenced application;

cited in the specification of the above-referenced application; or

X cited as an "X" or "Y" document in a foreign Patent Office search report on a foreign counterpart application a copy of which report is also enclosed.

I hereby certify that these documents were cited in said search report not more than three (3) months ago

Please charge any fee under 1.17(p) for this Information Disclosure Statement to be considered, not exceeding \$240.00, to Account No. 14-1270.

If readily available, English-language counterparts have been substituted for foreign-language patent documents. This disclosure is not an admission that any of these documents is material to or even prior art with respect to the above-referenced application.

Respectfully submitted,

By 
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CERTIFICATE OF MAILING

It is hereby certified that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:

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On June 5, 2001
By Valerie Neas